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		Application Number		10752396	
	NFORMATION DISCLOSURE	Filing Date		2004-01-06	
		First Named Inventor Lui		Luis Eduardo Gutierrez-Sheris	
	STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Art Unit		3685	
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	3	6012048	A	2000-01-04	Robin Haley Gustin, et al.		
	4	6206283	В	2001-03-27	Pradeep K. Bansal, et al.		
	5	6439456	В	2002-08-27	Pradeep K. Bansal, et al.		
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	8	6609113	В	2003-08-19	Denis O'Leary, et al.		

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